

Ⓢ Pending

 Active

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L1: (2) (('6596655') or ('6348725')).PN.
L2: (24140) low near (dielectric or constant
L3: (189) 2 and organosiloxane$1
L4: (118) 3 and cyclic
L5: (83) 4 and dielectric.clm.
L6: (55) 5 and (RF near power)
L7: (15) 6 and ((ring or cyclic) near organo
L8: (2) (('5976979') or ('6124641')).PN.
L9: (19) (('6,642,157') or ('6,596,655') or
L10: (0) 9 and precursor$1
L11: (14) 9 and precursor$1
L12: (5) 11 and organosil$5
L13: (13) (('6,331,494') or ('6,312,793') or
L14: (5) 13 and organosil$6
L15: (3) 14 and (low near dielectric)

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3 Failed

 Saved

(8) ("6475874") or ("6372561") or ("636544E")
(5) ("6524954") or ("6475874") or ("6316362")

10		Almond	Quine	Clas
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28: USPAT US 46480

ひまわり

♥ Highlighted in red as relevant

14 and (low near dielectric)

	U	I	PT	P	Document ID	Issue Date	Pages	Title	Current OR	Current XR	Retrieval	Inventor	#	C	Image D
1	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6147009	20001114	11	Hydrogenated oxidized silicon carbon material	438/780	257/E23.11	1	Grill, Alfred et al.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6147
2	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6066884	20000530	14	Method of making low kappa dielectric incor	427/255.6	257/E23.26	1	Rose, Peter et al.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 6066
3	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 5989998	19991123	21	Method of forming interlayer insulating f	438/623	257/E21.26	1	Sugahara, Gaku et al.	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 5989

Color	Size	Brand	Genre	Class
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PE4	USPAT 6,606,018	<input checked="" type="checkbox"/> Exact
Derivative no.	00	<input checked="" type="checkbox"/> High-throughput screening

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19 and (c adj o adj bond$1)
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	U	I	PT	P	Document ID	Issue Date	Pages	Title	Current OR	Current XP	Retrieval	Inventor	S	C	Image D	
1	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20030060302	20030327	15	Highly durable and abrasion resistant comp	473/282			Rogers, Joseph J. et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20030060302
2	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20020032073	20020314	15	HIGHLY DURABLE AND ABRASION RESISTANT COMP	473/324	473/349		ROGERS, JOSEPH J. et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20020032073
3	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 6054546	20000425	10	Solvent-free two-liquid type normal temperature	528/15	524/267; 524/730;		Suzuki, Tomio et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 6054546
4	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 5393641	19950228	6	Radiation-sensitive resin composition	430/270.1	520/296; 430/325;		Ito, Toshio et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 5393641
5	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 5292799	19940308	22	Solvent-free, cold-setting organosilo	524/783	524/779; 524/786;		Neito, Hiroyuki et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 5292799
6	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 4593114	19860603	8	Direct process for preparing dimethylsilox	556/450	556/452; 556/453;		Lewis, Kenrick M. et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 4593114